



CYPR-CD01171M

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Ogami et al.

Serial: 10/002,726

Group Art Unit: 2825

Filed: October 24, 2001

Examiner: Vuthe Siek

For: METHOD AND APPARATUS FOR GENERATING
MICROCONTROLLER CONFIGURATION INFORMATION

Honorable Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

RESPONSE

Dear Sir:

In response to the non-final Office Action mailed June 10, 2005 in the above captioned Patent Application, Applicants respectfully request the Examiner to consider the following remarks.